

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77312

Hiroshi TANABE, et al.

Divisional of Appln. No. 08/866,331  
Filed: May 30, 1997  
Confirmation No. 9640

Group Art Unit: 2822  
Examiner: Mary A. WILCZEWSKI

Appln. No.: Unassigned  
Filed: October 1, 2003

Group Art Unit: Unassigned

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND MANUFACTURING  
METHOD OF THIN FILM SEMICONDUCTOR DEVICE

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR §§ 1.97 and 1.98**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

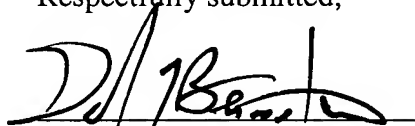
In accordance with the duty of disclosure under 37 CFR §1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form which are all the references of record in parent application No. 08/866,331. Applicant is not submitting duplicate copies of these references but requests that they be listed on the face of any patent granted on the above application. (See 37 CFR §1.98(d)). Copies of any cited copending applications, if not previously submitted, are being submitted herewith.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not

INFORMATION DISCLOSURE STATEMENT  
Divisional of Application No. 08/866,331

waive any right to take any action that would be appropriate to antedate or otherwise remove any  
listed document as a competent reference against the claims of the present application.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "H. Bernstein", written over a horizontal line.

Howard L. Bernstein  
Registration No. 25,665

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: October 1, 2003

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| Substitute for Form 1449 A & B/PTO<br><br><b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><br><i>(use as many sheets as necessary)</i> |   |    |   | <i>Complete if Known</i> |                          |
|  |   |    |   | Application Number       | Divisional of 08/866,331 |
|  |   |    |   | Confirmation Number      | Not yet assigned         |
|  |   |    |   | Filing Date              | October 1, 2003          |
|  |   |    |   | First Named Inventor     | Hiroshi TANABE           |
|  |   |    |   | Art Unit                 | 2822 (Parent)            |
|  |   |    |   | Examiner Name            | Not yet assigned         |
| Sheet  | 1 | of | 2 | Attorney Docket Number   | Q77312                   |

| U.S. PATENT DOCUMENTS |                       |                 |                                      |                                |   |
|-----------------------|-----------------------|-----------------|--------------------------------------|--------------------------------|---|
| Examiner Initials*    | Cite No. <sup>1</sup> | Document Number |                                      | Publication Date<br>MM-DD-YYYY | Name of Patentee or Applicant of Cited Document |
|                       |                       | Number          | Kind Code <sup>2</sup><br>(if known) |                                |   |
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| Examiner Initials*       | Cite No. <sup>1</sup> | Foreign Patent Document   |                     |                                      | Publication Date<br>MM-DD-YYYY | Name of Patentee or<br>Applicant of Cited Document | Translation <sup>6</sup> |
|                          |                       | Country Code <sup>3</sup> | Number <sup>4</sup> | Kind Code <sup>5</sup><br>(if known) |                                |  |                          |
|                          |                       |                           |                     |                                      |                                |  |                          |

| NON PATENT LITERATURE DOCUMENTS |                       |  |                          |
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| Examiner Initials*              | Cite No. <sup>1</sup> | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published. | Translation <sup>6</sup> |
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| Examiner Signature |  | Date Considered |  |
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|  |   |    |   | Examiner Name            | Not yet assigned         |
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|                          |                          | Country<br>Code <sup>3</sup> | Number <sup>4</sup> | Kind Code <sup>5</sup><br><i>(if known)</i> |                                |  |                          |
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|                                 |                          |  |                          |

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